

Doc code: IDS

PTO/SB/08a (01-10)

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	Filing Date		2006-06-20
	First Named Inventor	Peter Dirksen	
	Art Unit	1795	
	Examiner Name	Thori Chea	
	Attorney Docket Number	NL040617US1	

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	4	5373806		1994-12-20	LOGAR	
	5	4509852		1985-04-09	TABARELLI ET AL	
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